

INVENTOR INFORMATION

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CORRESPONDENCE INFORMATION

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APPLICATION INFORMATION

Title Line One:: METHOD OF FORMING SILICON-BASED THIN FILM,
Title Line Two:: SILICON-BASED THIN FILM AND PHOTOVOLTAIC
Title Line Three:: ELEMENT

Total Drawing Sheets:: 5
Formal Drawings?: Yes
Application Type:: Utility
Docket Number:: 35.C15381
Secrecy Order in Parent Appl.?: No

REPRESENTATIVE INFORMATION

Representative Customer Number:: 05514

PRIOR FOREIGN APPLICATIONS

Foreign Application One:: 2000-162805

Filing Date:: 05-31-2000

Country:: Japan

Priority Claimed:: Yes